## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoyuki KOBAYASHI et al.

Application No.: New U.S. National Phase of

PCT/JP2005/001990

Filed: August 2, 2006

Docket No.: 128977

For:

EXPOSURE APPARATUS, EXPOSURE METHOD, AND METHOD FOR

PRODUCING DEVICE

## **PRELIMINARY AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.